P.O.Box 1450, Alexandria	a, VA	22313-1450
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Transmitted herewith for filing is the Patent Application of:

இார் CHIH-MING KE, CHEN-HSUN LIN, YAO-CHING KU

CD SEM AUTOMATIC FOCUS METHODOLOGY AND APPARATUS FOR CONSTANT ELECTRON BEAM DOSAGE

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Sir:

X	2 sheets of drawing(s) - formal.
х	An assignment of the invention to Taiwan Semicondutor Manufacturing Co.
	An associate power of attorney Applicant claims small entity status
	Request & Certification under 35 USC 122(b)(2)(b)(i)

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN	A SMALL ENTITY
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 750.
TOTAL CLAIMS	30 -20=	10	x 18≃	\$ 180.
INDEP CLAIMS	2 -3=	0	x 84 =	\$0.
		SI	JB TOTAL	\$ 930.
	•	<u>A</u>	SSIGNMENT	\$40.
		T	OTAL	\$ 970.

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